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(12) **United States Design Patent** (10) **Patent No.:** **US D826,185 S**  
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(54) **CEILING HEATER FOR SUBSTRATE PROCESSING APPARATUS**

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(52) **U.S. Cl.**  
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(58) **Field of Classification Search**  
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D15/140, 144.1  
CPC ..... H01L 21/67011; H01L 21/67098; H01L  
21/67103; H01L 21/67109; H01L  
21/67115

See application file for complete search history.

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(57) **CLAIM**

We claim the ornamental design for a ceiling heater for substrate processing apparatus, as shown and described.

**DESCRIPTION**

FIG. 1 is a front, bottom and right side perspective view of a ceiling heater for substrate processing apparatus showing our new design;

FIG. 2 is a front elevational view thereof;

FIG. 3 is a left side elevational view thereof;

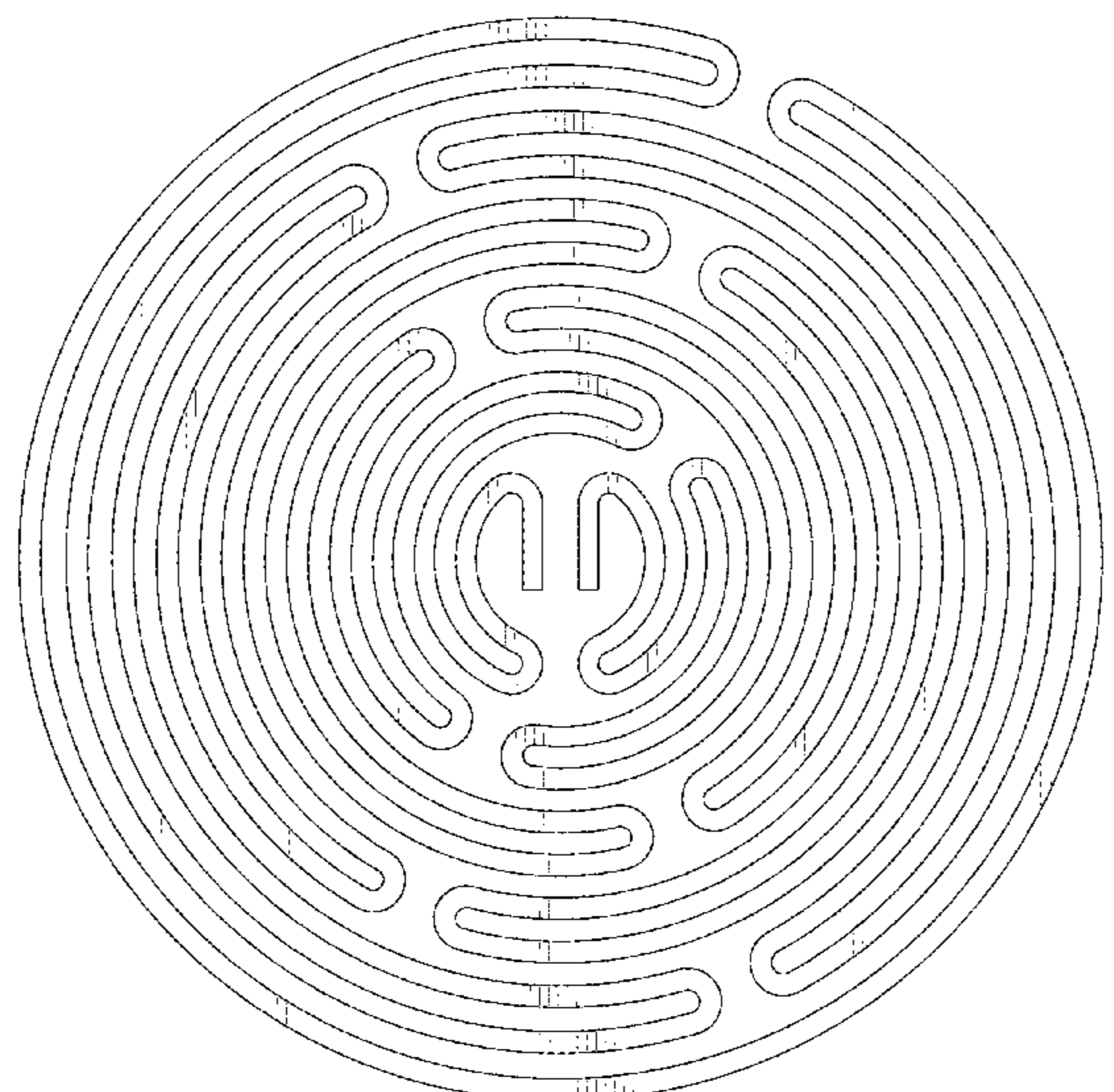
FIG. 4 is a right side elevational view thereof;

FIG. 5 is a top plan view thereof;

FIG. 6 is a bottom plan view thereof; and,

FIG. 7 is a rear elevational view thereof.

**1 Claim, 4 Drawing Sheets**



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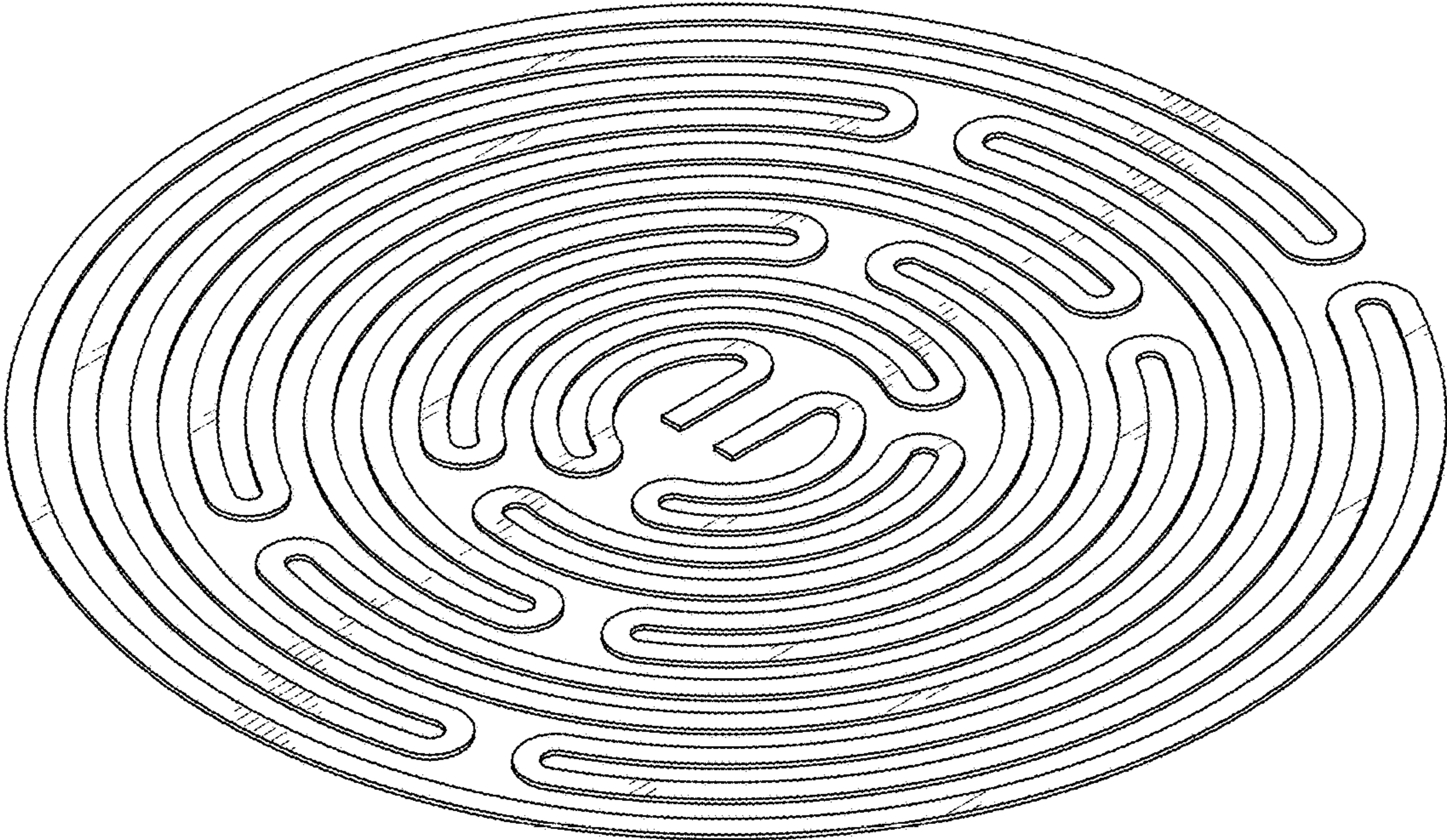


FIG. 1

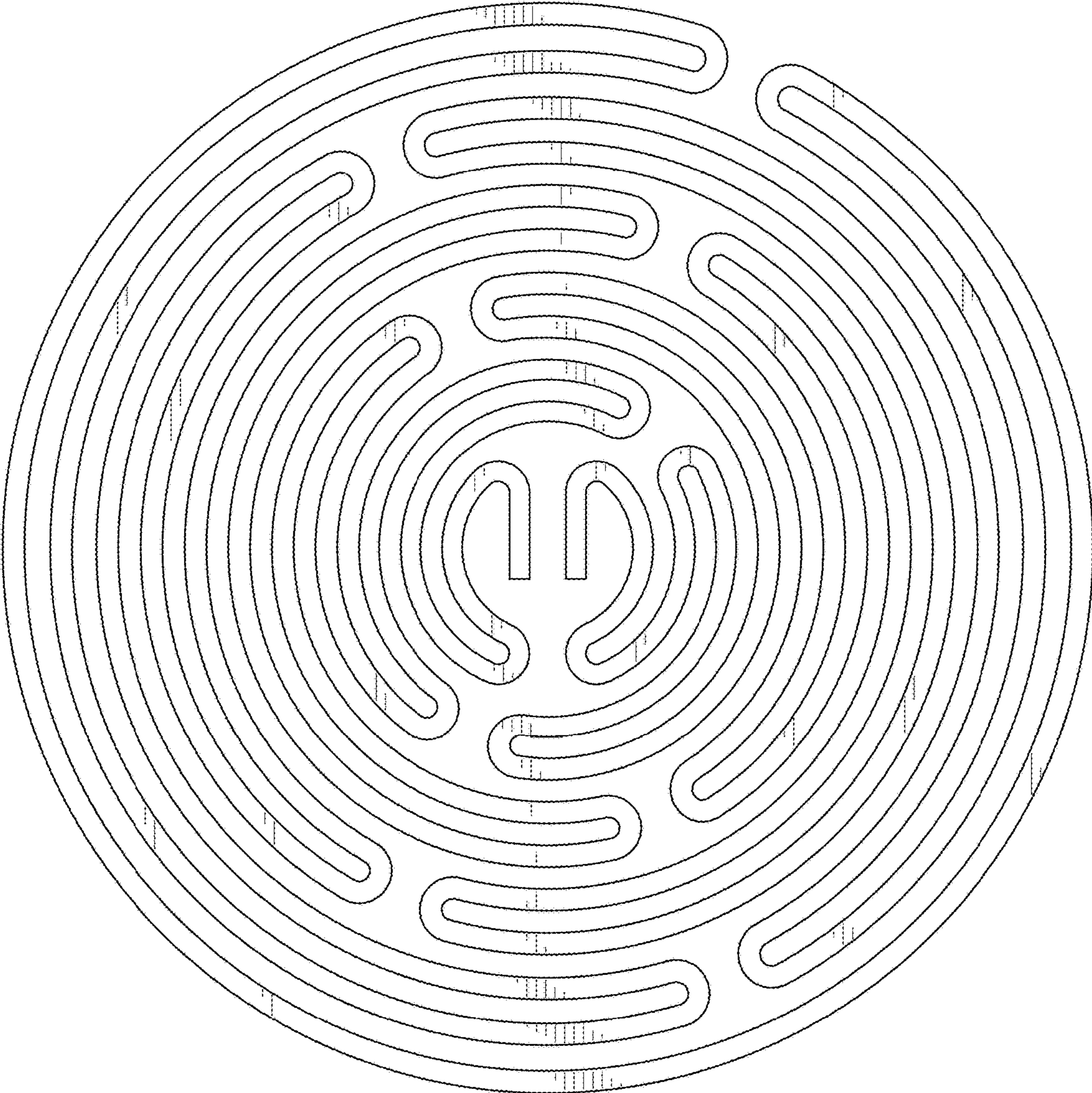


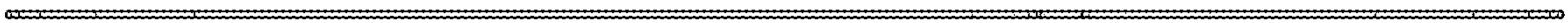
FIG. 2



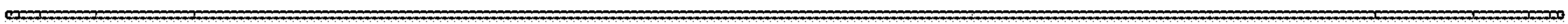
*FIG. 3*



*FIG. 4*



*FIG. 5*



*FIG. 6*

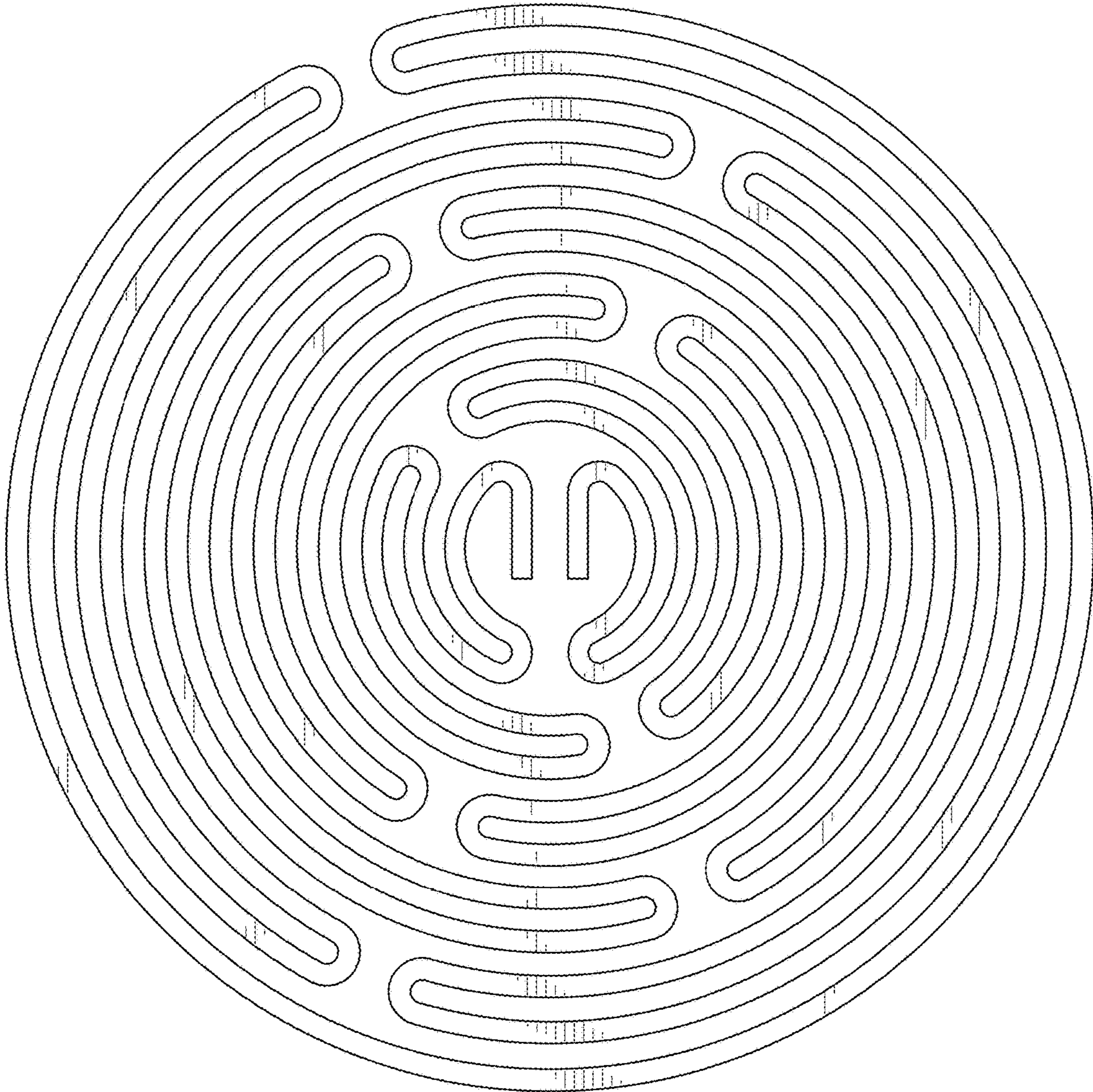


FIG. 7